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Front Matter: Volume 11185

, "Front Matter: Volume 11185," Proc. SPIE 11185, Optical Design and Testing IX, 1118501 (29 November 2019); doi: 10.1117/12.2560515

SPIE.

Event: SPIE/COS Photonics Asia, 2019, Hangzhou, China

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Optical Design and Testing IX

Yongtian Wang
Pablo Benítez
Osamu Matoba
Editors

21–22 October 2019
Hangzhou, China

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Volume 11185

Proceedings of SPIE 0277-786X, V. 11185

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Optical Design and Testing IX, edited by Yongtian Wang, Pablo Benítez,
Osamu Matoba, Proc. of SPIE Vol. 11185, 1118501 · © 2019 SPIE
CCC code: 0277-786X/19/\$21 · doi: 10.1117/12.2560515

Proc. of SPIE Vol. 11185 1118501-1

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Author(s), "Title of Paper," in *Optical Design and Testing IX*, edited by Yongtian Wang, Pablo Benítez, Osamu Matoba, Proceedings of SPIE Vol. 11185 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X
ISSN: 1996-756X (electronic)

ISBN: 9781510630871
ISBN: 9781510630888 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
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